

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

LASER IRRADIATION

METHOD, LASER

IRRADIATION APPARATUS

AND METHOD FOR

MANUFACTURING

SEMICONDUCTOR DEVICE

Attorney Docket Number::

0756-7283

Total Drawing Sheets::

15

Small Entity?::

No

Applicant Information

Applicant Authority Type:: Inventor

Primary Citizenship Country:: Japan

Given Name:: Koichiro

Middle Name::

Family Name:: TANAKA

Name Suffix::

City of Residence:: Atsugi

State or Province of Residence:: Kanagawa

Country of Residence:: Japan

Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase
Atsugi-shi
Kanagawa-ken
Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Hidekazu
Middle Name::
Family Name:: MIYAIRI
Name Suffix::
City of Residence:: Tochigi
State or Province of Residence:: Tochigi
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase
Atsugi-shi
Kanagawa-ken
Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan

Given Name:: Hironobu
Middle Name::
Family Name:: SHOJI
Name Suffix::
City of Residence:: Machida
State or Province of Residence:: Tokyo
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Correspondence Information

Correspondence Customer Number :: 31780
E-Mail address:: erobinson@riplo.com

Representative Information

Representative Customer Number:: 31780

Domestic Priority Information

| Application :: | Continuity Type:: | Parent Application:: | Parent Filing Date:: |
|----------------|-------------------|----------------------|----------------------|
| | | | |

Foreign Priority Information

| Country:: | Application number:: | Filing Date:: | Priority Claimed:: |
|-----------|----------------------|---------------|--------------------|
| Japan | 2003-101312 | 04/04/2003 | Yes |

Assignee Information

Assignee name:: Semiconductor Energy
Laboratory Co., Ltd.

Street of mailing address:: 398 Hase

City of mailing address:: Atsugi-shi

State or Province of mailing address:: Kanagawa-ken

Country of mailing address:: Japan

Postal or Zip Code of mailing address:: 243-0036